Optical communication link using micromachined corner cube reflector

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\begin{abstract}
An optical communication link using a micromachined corner cube reflector (CCR) was demonstrated to transmit digital signals over a range of 2 meters by reflecting an interrogating laser from a 5mW laser source. The surface micromachined CCRs are made of 250µm square hinged polysilicon plates and have measured reflectance ranging from 34\% to 77\% for different mirror designs. Light reflected by the CCRs has a divergence ranging from 15-35mrad. The CCRs are electrostatically actuated with 10 to 20V. The highest data rate transmitted with a CCR is 1K bps. Theoretical analysis and some dynamic optical test results of the device are presented.

\textbf{Keywords:} Corner cube reflector, polysilicon, micro-optics, surface micromachining, serial communication, electrostatic actuator
\end{abstract}

\section{1. \textsc{Introduction}}

\begin{figure}[h]
\centering
\includegraphics[width=0.5\textwidth]{diagram.png}
\caption{Schematic diagram of a communication system using CCR as an optical wireless link.}
\end{figure}

Zwirn proposed using a MEMS corner cube reflector to transmit digital signals by modulating the shape of the corner.\textsuperscript{1} A corner cube reflector (CCR) has three mutually orthogonal reflective surfaces which form a concave corner. The mutual orthogonality insures that light which shines at the concave corner will be reflected directly back to the direction of the light source. By changing the shape of the CCR, the CCR can intermittently reflect an interrogating light to its source direction. A photo detector at the light source can then detect this modulated light from the CCR.

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Fig. 1 shows one strategy of using a CCR as a communication link in a system. Consider a system which has a base station with a laser source and a remote station with an embedded sensor and a CCR. The remote station modulates the shape of the CCR according to the output of the sensor or some encrypted messages. The base station can shine a laser at the CCR of the remote station to read messages. In order to ignore signals from other light sources, the base station can also couple a frequency “signature” to the laser directed at the remote station and only read signals with the signature frequency.

Using CCRs as wireless communication links has several advantages including low power, small size, and low cost. The transmitter with a CCR may consume minimal power since it transmits data by reflecting external power. A corner cube reflector removes the need for precise angular alignment between the laser source and the CCR. The reflector can be fabricated with dimensions in the millimeter or sub-millimeter range depending on the application need. Batch fabrication technology for micromachining could also yield low cost systems. As a result, remote stations with micromachined sensors and CCR transmitters have the potential to be low powered, autonomous, small (<< 1cm$^3$) and inconspicuous, so that a large distribution of remote stations may be possible. The disadvantages of this communication approach include the need for a more complex base station and line of sight communication.

Hinged polysilicon plates fabricated by surface micromachining can readily be used as micro mirrors and lenses.\textsuperscript{2,3} Earlier efforts in developing surface micromachined CCRs have been reported.\textsuperscript{4,5} In this paper, the operation principles of CCRs will be discussed. Some novel designs of microstructure components including an electrostatic actuator will be presented. Analysis and simulation of the electrostatic design will also be presented. The optical testing of fabricated CCRs and the realization of a communication system using a micro CCR as a communication link will be discussed.

2. CORNER CUBE REFLECTOR THEORY

An ideal corner cube reflector has 3 perfectly reflective, mutually orthogonal planar surfaces which together form a right angle concave corner. For a macro corner cube (which is much bigger in size than the incident beam spot size), it can be shown that an incident ray with direction $\hat{a} = (-a_x, -a_y, -a_z)$, with $||\hat{a}|| = 1$ and $a_x, a_y, a_z \geq 0$, will be reflected back to the direction $-\hat{a}$ after it hits three mirror surfaces of the CCR (Fig. 2).\textsuperscript{6,7} The light ray may also return to its source after two bounces or even one bounce if the appropriate component of the incident direction is zero. In this application, we are most interested in the three bounce case because it is most likely that the incident light has a direction with non-zero $a_i$. Since micro CCRs generally are assumed to be smaller in size than the incoming beam, we are also interested in the total effective area of the CCR.

Suppose an incident ray with direction $(-a_x, -a_y, -a_z)$ struck the x-y mirror at $p_1 = (x_1, y_1, 0)$, and then the x-z mirror and the y-z mirror at $p_2 = (x_2, 0, z_2)$ and $p_3 = (0, y_3, z_3)$ respectively (Fig. 2). The following conditions can
be derived for \( p_i \) in terms of \( a_i \)'s for the case where \( 0 < y_1 < (a_y/a_x)x_1 < 1 \) and \( a_y/a_x \leq 1 \):

\[
0 < y_1 < \frac{a_y}{a_x} < 1 \quad \text{and} \quad 0 < x_1 < \frac{a_x}{a_z} < 1
\]

for all \( a_i \geq 0 \). An additional condition

\[
y_1 > \frac{a_y}{a_x}x_1 - 1
\]

is found for \( a_y/a_x > 1 \). Similar conditions can be derived for the case where the light ray first hits the x-z mirror, followed by the y-z mirror and the x-z mirror.

We can conclude that a light ray of a given direction can be reflected back to its source only if it hits a particular region of the CCR. In other words, the effective area of a CCR changes as a function of the direction of an incident ray. Fig. 3 shows the area on the CCR where an incident ray must first hit in order to be returned to the source. The effective area is the sum of each shaded area scaled by the corresponding direction cosine of the incident ray. The maximum effective area for a unit corner cube, thus, is \( \sqrt{3} \). The direction which yields the largest effective area is \( \frac{1}{\sqrt{3}}(1,1,1) \), although small deviation from this direction does not reduce the area significantly. For example, if the incident direction is within a solid angle of 0.3 rad around \( \frac{1}{\sqrt{3}}(1,1,1) \), the effective area is at least 50% of the maximum area, yielding less than 3 dB of power loss.

Given the effective area and the incident beam spot size, the reflected power may be estimated by the following equation:

\[
P_{\text{reflected}} = P_{\text{incident}} \times \frac{A_{\text{CCR}}}{A_{\text{spot}}} \times R_{\text{CCR}}
\]

The reflected power is also directly proportional to incident power, \( P_{\text{incident}} \), and the reflectivity of the mirrors, \( R_{\text{CCR}} \). \( R_{\text{CCR}} \) is equal to the product of the reflectivity of each of the three mirrors. The reflectivity is determined by the fabrication process. For polysilicon plates, the reported reflectance is 24% for 0.67 \( \mu \)m wavelength.\(^5\) For gold coated polysilicon plates, the reported reflectance is 0.93 for 1.3 \( \mu \)m wavelength\(^8\) (gold's ideal reflectance is 0.99 for \( \lambda = 1.3 \mu \)m and 0.97 for \( \lambda = 0.67 \mu \)m\(^6\)).

In a communication system like the one in Fig. 1, the actual detectable power by the sensor located at the receiver also depends on the area of the sensor's aperture, the communication distance, atmospheric attenuation, and the divergence of the reflected beam. For the following analysis, we will assume that the CCR is ideal. The detected power at the sensor may be approximated by

\[
P_{\text{detected}} = P_{\text{reflected}} \times \frac{A_{\text{sensor}}}{(\theta_{\text{CCR}} R)^2} \times (\text{atmos. attenuation})
\]
\( (\theta_{CCR} R)^2 \) is the area illuminated by the CCR at a distance \( R \). Assume that the spreading of the reflected beam due to diffraction is Fraunhofer (where the CCR behaves like a square aperture with dimension \( d \)), then \( \theta_{CCR} \), the divergence of the beam reflected by the CCR, can be estimated by

\[
\theta_{CCR} \approx \sin^{-1}(\frac{\lambda}{d}) \approx \frac{\lambda}{d}
\]

where \( \lambda \) is the wavelength of the incident light.\(^{10}\) The area of the sensor’s aperture, \( A_{sensor} \), is arbitrary in the sense that lenses may be used to collect and focus the reflected light onto the sensor. However, this area should be made smaller than the area illuminated by the CCR.

In order to understand the effectiveness of using a micro CCR for communication, let us consider the signal to noise ratio which is defined as the following:

\[
SNR = \frac{P_{detected} \times \eta}{NEP}
\]

\( \eta \) is the quantum efficiency of the sensor (assume 0.8 for a silicon PIN diode detector), and NEP is the noise equivalent power (assume \( 10^{-11} W/\sqrt{Hz} \times \sqrt{10 kHz} = 10^{-12} W \)). Assume that atmospheric attenuation is negligible. Suppose we desire to communicate across a range of 200m by using a laser with \( \lambda \) of 0.67\( \mu \)m and a divergence of 1.5mrad, with a sensor aperture of 10cm in diameter. To achieve an SNR of 10, we may use an ideal micro CCR with \( A_{CCR} = \sqrt{\lambda(200 \mu m)^2} \), and a laser source of 1.7mW. Now suppose the range is increased by 5 times to 1km. In order to maintain the same SNR, if the size of the CCR is increased to 350\( \mu \)m and the sensor aperture diameter is increased to 20cm, then a 0.67\( \mu \)m laser source with 28mW would be needed.

Atmospheric effects such as beam spreading, absorption, scintillation, scattering, and beam bending could complicate the proposed optical communication strategy for large communication distances.\(^{11}\) The non-ideality of a fabricated CCR such as mirror curvature and poor orthogonality could also degrade the performance of a communication system using CCR as transmitters. However, from the analysis above, it is clear that a communication system like the one proposed in Fig. block could satisfy requirements for a variety of applications by a careful selection of CCR, laser, and detector.

### 3. MECHANICAL DESIGN OF CCR

We have designed micro CCRs which are surface micromachined via the MUMPS multiple layer polysilicon process offered by MCNC.\(^{12}\) Mirrors made of polysilicon plates with a gold layer are rotated to a position normal to the substrate using microhinges and are locked in place with torsional spring locks (Fig. 4). Tenon and mortise are used to help align the two vertical plates. Torsional tie-downs are connected to the edges of the rotated plates to restrict potential offset due to slack in the hinges. A fabricated electrostatic CCR is shown in Fig. 5. Additional plates
Figure 5. An electrostatically actuated polysilicon CCR with a 250\(\mu\)m corner. The motion of the bottom plate modulates the reflection from the corner. The plate as shown is in an “up” position (the CCR is off).

Figure 6. Bent beams are used to prevent the rotated mirror from being disassembled. To assemble the tilted mirror, a probe applies an axial force to buckle the microjack, lifting the locking beam, the mirror is then rotated into position (Fig. 4), and the locking beam is lowered.

with slits resting at an angle are used in this structure to catch the edge of the mirror plates in order to improve orthogonality.

The mechanical misalignment for the vertical plates and the substrate is estimated to be less than 2.8mrad. The movable base mirror also has a misalignment of 6.7mrad due to a layout error. Both misalignments can be reduced to less than 1mrad in future designs. Due to the tensile metal layers (300\(\AA\) Cr and 0.5\(\mu\)m Au) on the two-layer polysilicon plates, the mirrors have measured radius of curvature ranging from 7 to 9.8mm, which gives a reflected light ray an estimated divergence of 15 to 20mrad. The stresses estimated from these measurements using bending equations from composite materials\(^1\) agreed with MCNC’s measured values.\(^2\) The curvature in the plates may be reduced by putting polysilicon rims around the border of the gold mirrors. The curvature may also be reduced by decreasing the metal layer thickness or using different metals. Unfortunately, we lack this option since these process parameters are fixed by MCNC. From optical experiments, measured divergence for laser light reflected by CCRs like the one in Fig. 5 ranges from 15mrad to 35mrad.

Mirror plates typically have linear dimensions of 250 to 300\(\mu\)m. No etch holes are put in the plates in order to create smooth mirror surfaces. As a result, the chips from MCNC must be etched in 49% HF for up to 15 minutes in order to remove the sacrificial oxide layers. The long etch does not seem to cause any observable effect on the
gold or polysilicon layers. Following the HF etch, the chips are rinsed in DI water and then isopropanol, which is then evaporated by placing the chips on a hot plate. Generally, this alcohol release method avoids stiction problems.

Microstructures are then assembled using micro-manipulators at a microscope. Assembly is facilitated by the use of integrated microjacks (Fig. 6). The micro CCRs modulate the incident light by actuating a movable bottom mirror surface. The misalignment of one mirror of the CCR will deflect an incident light ray away from its source. The electrostatic CCR has a tilted bottom mirror surface which moves from an angled position (∼ 3deg or 52mrad) to a horizontal position when a voltage is applied across the tilted mirror and a substrate electrode (Fig. 7). The tilted mirror is made of a gold covered polysilicon plate which is rotated about several microhinges by a few degree less than 180 (Fig. 4) and is clamped down by beams (Fig. 6). A metal contact on the lower part of the rotated plate comes in contact with another metal contact on the substrate such that a voltage can be applied to the rotated plate. Two rails on the substrate help level the pulled-down mirror and prevent shorting between the conductive mirror and the substrate electrode (Fig. 7).

The actuated mirror takes advantage of the nonlinearity and instability found in a typical spring-mass-electrostatic system such that the mirror can be pulled down with relatively low voltages. Typically, an actuation voltage of 10 to 15 volts is adequate to move the tilted mirror to a flat position. Estimated capacitance of the electrostatic actuator is < 0.2 pF. When the CCR is driven with 20 V and 10 kHz voltage input, the estimated power consumption of the actuator is < 0.4 μW.

The flip-over actuated mirror design is not ideal because the polysilicon surface instead of the gold surface becomes the mirror. Fig. 8 shows an actuated mirror design with a gold reflective surface. It is made by a suspended plate
$$M_p \ddot{d} = \frac{V^2 \epsilon W}{2} \left[ \frac{-L}{2 \sin \left( \frac{\delta}{2L \sin \frac{\delta}{2}} \right)} \right]$$

$$+ \frac{EI}{L} \left[ \frac{-\phi^2}{4} \right]^{d_0 - d}_{\phi_0 - \phi}$$

$$- (1 - 0.6 \frac{W}{L} \left( \frac{\mu W^2 L}{d^4} \right)) \left[ \frac{d}{(\frac{d}{2})^2 \phi} \right]$$

where for $\phi \geq 0$,

$$\delta = d$$

and for $\phi < 0$,

$$\delta = d + 2L \sin \frac{\phi}{2}$$

$E$, $\epsilon$, and $\mu$ represent Young’s modulus of polysilicon, permittivity of free space, and viscosity of air. Other variables are explained in Table 1.

The electrostatic actuator is modeled as a non-parallel capacitor. First, the electric field is found by solving Laplace’s equation in polar coordinates as a function of the radial distance, neglecting the effect of fringing field. The capacitance is calculated using Gauss’ law for electricity. The total energy is then calculated. The force applied
Figure 9. Simulated deflection and angle of the bottom plate in Fig. 7 as a function of input voltages. Simulated pull-in voltage is 15.3V.

to the support beams is calculated by taking a partial derivative of the total energy with respect to the vertical separation. The moment applied to the support beams is calculated by summing the product of the force due to a differential areas and the corresponding distances from the areas to the axis of rotation. The axis of rotation is along the points where the beams and the mirror are connected. The expressions of the electrostatic force and moment are shown as the first terms on the right side of the system equation.

Figure 10. Simulated positions of the bottom plate in Fig. 7 as it goes from the “down” position to the “up” position.

The two support beams of the actuated mirror are modeled as ideal linear fixed-end rectangular beams with a force and moment load at the tip of the free end. The force and moment expressions are shown as the second term on the right side of the system equation. The damping force in the system is modeled by squeeze-film damping, and the damping moment is calculated by multiplying the damping force by the distance from the center of the mirror to the axis of rotation. The damping expressions are shown as the last term of the right side of the system equation.

The system equation in Eq. 7 describes the mirror’s motion only when the mirror is not in contact with any rails on the substrate. To simulate the complete down-up cycle, one needs to recognize when one or more edges of the mirror collide with the rails and switch to a different model which takes into account of the applied force from the rails. The system equation is simulated with Matlab using Simulink and the Runge-Kutta fifth order method.

The model predicts a voltage at which the electrostatic force will overwhelm the spring force, as seen in parallel-plate electrostatic systems.\textsuperscript{14} Fig. 9 shows the simulated equilibrium positions of an actuator with voltage input
Figure 11. Raw output of photo detector for different CCR modulation frequencies. Direction of incident light is near (-1,-1,-1). The square wave represents the input signal which modulates the CCR, where a low input pulls down the movable mirror. Actuation voltage is 15V.

from 0 to the predicted pull-in voltage of 15.3 V. The predicted voltage agrees well with experimentally observed pull-in voltages for this actuator, which cluster around 15 V. The increase in plate angle when the applied voltage approach 15V suggests that the unsupported mirror edge will first collide with a rail during a pull-down. This effect has also been observed.

Fig. 10 shows the simulated motion of the plate from a “pull-down” position to an idle position with no applied voltage. The natural frequency of the actuator is simulated to be 550Hz. Work is in progress to verify further the accuracy of this model.

5. DYNAMIC OPTICAL EXPERIMENT RESULTS

Optical bench tests in a dark room were performed on a number of fabricated devices. A 670nm Helium-Neon laser was shined at a modulated CCR through a beam splitter, and the returned light from the CCR was directed to a silicon PIN photo-diode with responsivity of about 0.45A/W for the wavelength of interest. A simple optical setup like this one does not provide precise information about the motion of the actuator due to the nonlinearity of the photo detector; however, it shows how the CCR will be seen by an interrogating laser source during a transmission in the absence of background noise.

Fig. 11 shows the raw signals (with no amplification) from the detector at the oscilloscope when the CCR in Fig. 5 is driven at different modulation frequencies. The square waves represent the input signal to the circuit which powered the CCR, where a low input activates the CCR. The high level of the detector waveforms correspond to increased intensity detected by the photo diode. Fig. 11 show that the detector waveforms change in shape and magnitude as the frequency changes.

At low frequencies, the change in detector output could be as high as 260mV (corresponding to about 0.5μW), with a relatively small DC offset of 50mV. Peaks are often observed before the rising and falling edges of the detector output. The source of these peaks is still unclear, although both Fig. 10 and Fig. 11 suggest that reflective transitions may occur more than once during each cycle. The rise time and delay of the rising edge have been observed to decrease with increased applied voltage (beyond the pull-in voltage). At high frequencies, the AC component of the detector waveform begins to decrease in amplitude while the voltage peak remains constant, indicating that the actuated
Figure 12. Magnitude plot of the intensity change of the photo detector waveform as a function of CCR modulation frequency.

Figure 13. Waveform and magnitude plots of the intensity change of the photo detector waveform as a function of CCR modulation frequency. The incident angle as well as the observed spot location are changed from Fig. 11. Actuation voltage is 18V.

mirror lacks time to move away from the pull-down position. Fig. 12 shows the AC magnitude change versus the frequency. The -3dB point occurred at 444Hz. It has also been observed that the detector waveform may change in intensity and shape depending on the direction of the incident light, yielding a different frequency magnitude plot (Fig. 13).
6. CCR AS A COMMUNICATION LINK

To demonstrate the operation of the fabricated micro CCR, a palm-size transmitter and a similar sized receiver have been built (Fig. 14). This transceiver can transmit either a periodic or an arbitrary digital signal from the transmitter to the receiver. The prototype transceiver system with the micro CCR operates in the arrangement shown in Fig.1, where the receiver’s laser beam is aimed at the CCR of the transmitter. A light emitting diode (LED) on the transmitter blinks according to the signal being transmitted, while another LED on the receiver blinks in synchrony when the receiver successfully detects the reflected signal.

The transmitter module is powered by a 9-volt battery. The chip with the micro CCR is glued and wire-bonded to a plastic substrate with copper bonding pads. The plastic substrate with the chip is stored inside a transparent petri dish to prevent damage to the CCR.

The receiver module contains a laser diode module from a commercially available laser pointer with wavelength of about 670nm. The receiver modulate the laser at 2kHz thus outputting a laser beam of 1.7mW rms power. The receiver module uses a beam splitter to direct the returned light to a 2cm diameter lens which focuses the light onto a silicon PIN photo detector (Fig. 1). This detection scheme allows a compact system but is not ideal since the outgoing laser and the returning laser are reduced in power by half. The modulated signal returned from the CCR is high-pass filtered and amplified. The signal then goes through a threshold comparator to remove additional noise and is integrated to retrieve the actual transmitted data.

Free space communication across a distance of more than 1m under normal room light was demonstrated. With a CCR not covered with a petri dish lid, a distance of 2.1m has also been demonstrated. Highest observed communication rate transmitted and detected with the prototype is 1K bps. This prototype system did not demonstrate the low-power and miniature-size advantages offered by micro CCRs; however, it provided proof of concept for the use of micro CCRs in free-space communication.

7. CONCLUSION

We have fabricated micro CCRs with a novel electrostatic actuator using surface micromachining. These CCRs have been demonstrated to function as a transmitter in an optical wireless transceiver system. Test results show that CCR with 77% reflection efficiency is feasible. Optical signals reflected from the CCR have been presented. A non-linear model has also been designed for the CCR actuator to improve understanding of the behavior of the CCR. Future work will include modification of the CCR design to improve bandwidth, optical quality, and voltage requirement, designing a miniature low-power transmitter using the CCR, and evaluating its performance in a digital communication network.

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